

SONNENSCHEIN, NATH & ROSENTHAL

8000 Sears Tower 233 S. Wacker Drive Chicago, IL 60606

312/876-0200

APPLICANTS:

Shinichiro Yamada et al.

ATTY DOCKET NO:

09792909-4734

SERIAL NO.:

09/747,627

GROUP ART UNIT:

1745

DATE FILED:

December 22, 2000

EXAMINER:

J. Crepeau

INVENTION:

"METHODS OF PRODUCING NEGATIVE ELECTRODE

MATERIAL, NEGATIVE ELECTRODE, AND NON-AQUEOUS

ELECTROLYTE BATTERY"

AMENDMENT "B" AFTER FINAL

BOX AF, Hon. Assistant Commissioner of Patents

Washington D.C. 2023

SIR:

Transmitted herewith is an amendment in the above-identified application.

Additional claim fee is required.

The fee has been calculated as shown below.

		CLAIMS AS AMENDE	ED		
(2) CLAIMS REMAINING AFTER AMENDMEN		HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONA FEE
TOTAL CLAIMS	MINUS		0	() X 9.00 () X 18.00	0.00
INDEP. CLAIMS	MINUS		0	() X 39.00 (5) X 84.00	0.00
Application amended to contain any multiple dependent claims not previously paid for.		() YES (X) NO	() \$135.00 () \$270.00 ONE TIME		
	- 1	TOTAL ADDITIONAL FEE FOR THIS AMENDMENT		\$0.00	

Applicant petitions the Commissioner of Patents and Trademarks to extend this time for response to the _____ for _ months so that the period for response is extended to _ Office Action dated

The Commissioner is hereby authorized to charge the extension of time fee of \$_____ to deposit account no. 19-3140.

A check in the amount of \$____ is attached to cover the additional claim fee.

The Commissioner is hereby authorized to charge any additional fees which may be required, or to credit any overpayment to account No. 19-3140. A duplicate of this sheet is enclosed. When phoning re this application, please call 312/876-8000 - Ext. 2606.

SONNENSCHEIN NATH & ROSENTHAL

DATE: January 27, 2003

Christopher P. Rauch (Reg. No. 45,034)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited as first class mail in an envelope addressed to BOX AF, Asst. Commissioner of Patents, Washington, D.C. 20231 on January 27, 2003.

Christopher P. Rauch